



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

February 18, 2026	
IGI Report Number	LG774676102
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	SQUARE EMERALD CUT
Measurements	9.11 X 8.83 X 5.86 MM

GRADING RESULTS

Carat Weight	4.51 CARATS
Color Grade	D
Clarity Grade	SI 1

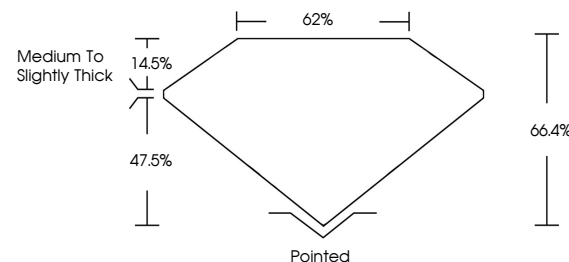
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	151 LG774676102

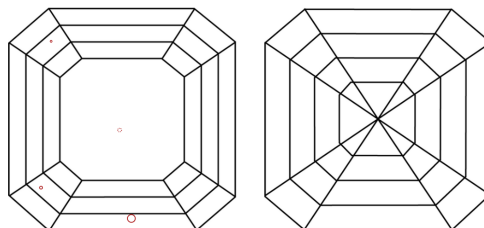
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG774676102
Report verification at lgi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

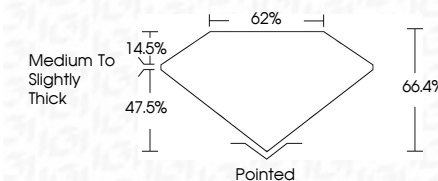
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February 18, 2025	4.51 CARATS
Q1 Report No. LG774676102	D
SQUARE EMERALD CUT	S 11
	66.4%
	62%
	Thick
	Medium to Slightly Thick
	Pointed
	EXCELLENT
	EXCELLENT
	NONE
	681 LG774676102

Comments: This is a very poor diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIA